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UTILITY PATENT APPLICATION TRANSMITTAL

(Only for new nonprovisional applications under 37 CFR 1.53(b))

APPLICATION ELEMENTS

See MPEP chapter 600 concerning utility patent application contents.

1. Fee Transmittal Form (e.g., PTO/SB/17)
(Submit an original and a duplicate for fee processing)
2. Applicant claims small entity status.
See 37 CFR 1.27.
3. Specification [Total Pages **25**]
(preferred arrangement set forth below)
 - Descriptive title of the invention
 - Cross Reference to Related Applications
 - Statement Regarding Fed sponsored R & D
 - Reference to sequence listing, a table, or a computer program listing appendix
 - Background of the Invention
 - Brief Summary of the Invention
 - Brief Description of the Drawings (*if filed*)
 - Detailed Description
 - Claim(s)
 - Abstract of the Disclosure
4. Drawing(s) (35 U.S.C. 113) [Total Sheets **1**]
5. Oath or Declaration [Total Pages **2**]
 - a. Newly executed (original or copy)
 - b. Copy from a prior application (37 CFR 1.63 (d))
(for continuation/divisional with Box 18 completed)
 - i. **DELETION OF INVENTOR(S)**
Signed statement attached deleting inventor(s) named in the prior application, see 37 CFR 1.63(d)(2) and 1.33(b)
6. Application Data Sheet. See 37 CFR 1.76

18. If a CONTINUING APPLICATION, check appropriate box, and supply the requisite information below and in a preliminary amendment, or in an Application Data Sheet under 37 CFR 1.76:

Continuation Divisional Continuation-in-part (CIP) of prior application No _____ / _____

Prior application information _____ Examiner _____

Group Art Unit _____

For CONTINUATION OR DIVISIONAL APPS only: The entire disclosure of the prior application, from which an oath or declaration is supplied under Box 5b, is considered a part of the disclosure of the accompanying continuation or divisional application and is hereby incorporated by reference. The incorporation can only be relied upon when a portion has been inadvertently omitted from the submitted application parts.

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FEE TRANSMITTAL for FY 2001

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TOTAL AMOUNT OF PAYMENT (\$)498

Complete if Known

Application Number	
Filing Date	
First Named Inventor	<u>Bon clurant</u>
Examiner Name	
Group Art Unit	
Attorney Docket No.	<u>waterjet -09 - 05</u>

METHOD OF PAYMENT

1. The Commissioner is hereby authorized to charge indicated fees and credit any overpayments to
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FEE CALCULATION (continued)

3. ADDITIONAL FEES

Large Entity Fee Code (\$)	Small Entity Fee Code (\$)	Fee (\$)	Fee Code (\$)	Fee (\$)	Fee Description	Fee Paid
105	130	205	65		Surcharge - late filing fee or oath	<input type="text"/>
127	50	227	25		Surcharge - late provisional filing fee or cover sheet	<input type="text"/>
139	130	139	130		Non-English specification	<input type="text"/>
147	2,520	147	2,520		For filing a request for ex parte reexamination	<input type="text"/>
112	920*	112	920*		Requesting publication of SIR prior to Examiner action	<input type="text"/>
113	1,840*	113	1,840*		Requesting publication of SIR after Examiner action	<input type="text"/>
115	110	215	55		Extension for reply within first month	<input type="text"/>
116	390	216	195		Extension for reply within second month	<input type="text"/>
117	890	217	445		Extension for reply within third month	<input type="text"/>
118	1,390	218	695		Extension for reply within fourth month	<input type="text"/>
128	1,890	228	945		Extension for reply within fifth month	<input type="text"/>
119	310	219	155		Notice of Appeal	<input type="text"/>
120	310	220	155		Filing a brief in support of an appeal	<input type="text"/>
121	270	221	135		Request for oral hearing	<input type="text"/>
138	1,510	138	1,510		Petition to institute a public use proceeding	<input type="text"/>
140	110	240	55		Petition to revive - unavoidable	<input type="text"/>
141	1,240	241	620		Petition to revive - unintentional	<input type="text"/>
142	1,240	242	620		Utility issue fee (or reissue)	<input type="text"/>
143	440	243	220		Design issue fee	<input type="text"/>
144	600	244	300		Plant issue fee	<input type="text"/>
122	130	122	130		Petitions to the Commissioner	<input type="text"/>
123	50	123	50		Processing fee under 37 CFR 1.17(q)	<input type="text"/>
126	180	126	180		Submission of Information Disclosure Stmt	<input type="text"/>
581	40	581	40		Recording each patent assignment per property (times number of properties)	<input type="text"/>
146	710	246	355		Filing a submission after final rejection (37 CFR § 1.129(a))	<input type="text"/>
149	710	249	355		For each additional invention to be examined (37 CFR § 1.129(b))	<input type="text"/>
179	710	279	355		Request for Continued Examination (RCE)	<input type="text"/>
169	900	169	900		Request for expedited examination of a design application	<input type="text"/>
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FEE CALCULATION

1. BASIC FILING FEE

Large Entity Fee Code (\$)	Small Entity Fee Code (\$)	Fee (\$)	Fee Description	Fee Paid
101	710	201	355	Utility filing fee
106	320	206	160	Design filing fee
107	490	207	245	Plant filing fee
108	710	208	355	Reissue filing fee
114	150	214	75	Provisional filing fee
SUBTOTAL (1) (\$) <u>710</u>				<input type="text"/>

2. EXTRA CLAIM FEES

Total Claims	Extra Claims	Fee from below	Fee Paid
21	-20** =	11 X 18 =	<u>209</u>
Independent Claims	- 3** =		
Multiple Dependent			

Large Entity Small Entity

Fee Code (\$)	Fee Code (\$)	Fee Description		
103	18	203	9	Claims in excess of 20
102	80	202	40	Independent claims in excess of 3
104	270	204	135	Multiple dependent claim, if not paid
109	80	209	40	** Reissue independent claims over original patent
110	18	210	9	** Reissue claims in excess of 20 and over original patent
SUBTOTAL (2) (\$) <u>289</u>				

**or number previously paid, if greater, For Reissues, see above

*Reduced by Basic Filing Fee Paid

SUBTOTAL (3) (\$)

SUBMITTED BY

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		Date	<u>11/15/2000</u>	

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1
2 Title Method and Apparatus for In Situ Inspection of Reformer Tubes

3

4 Field of Invention:

5 This invention pertains to the inspection of materials. In particular this invention pertains to
6 the inspection of the surface of materials for creep, metal dusting, irregularities, and manufacturing
7 flaws. With still greater particularity the invention pertains to the inspection of the interior of
8 cylindrical surfaces such as reformer tubes used in chemical processing.

9

10 Background of invention:

11 Reformer tubes are used in many chemical processes. Examples include tubes used to
12 produce ammonia, methanol, hydrogen, nitric and sulfuric acids, and cracking of petroleum.
13 Reformer tubes, also called catalyst tubes, are one of the highest cost components of such plants
14 both in capital and maintenance. A typical installation consists of several hundred vertical tubes.
15 These tubes represent a significant cost for replacement and can be a major source of plant
16 unavailability if unplanned failures occur.

17 Such tubes are frequently subjected to pressure changes and contact with corrosive
18 substances. Under such situations creep, metal dusting, and surface irregularities frequently
19 develop. If left untreated, creep will develop into cracks that will propagate leading to failure of the
20 tube.

1 The plant operator is faced with balancing production needs against tube life and risk of
2 tube failure. The Inner Diameter (ID) of these reformer tubes is generally between 76 mm (3.0
3 inches) and 127 mm (5.0 inches). During plant operation the catalyst filled tubes are externally
4 heated to allow the reforming reaction to occur. One of the major concerns in plant operation is that
5 the reformer tubes operate at an elevated temperature such that they are susceptible to a failure
6 mechanism referred to as "creep". This condition exists due to the elevated temperatures and
7 stresses imposed by internal pressure, thermal gradients, and mechanical loading cycles. Being able
8 to identify and locate such damage in its early stages is essential for optimizing plant operation.

9 Conventional Nondestructive Examination (NDE) inspection techniques currently applied to
10 reformer tubes are geared to finding creep damage in the form of internal cracking. However, with
11 the trend towards larger tube diameters and longer intervals between turnarounds, the detection of
12 such defects may not allow for sufficient time for forward planning of tube replacements. Also,
13 such "end of life" techniques do not allow any differentiation between the "good" tubes. Early
14 detection of underutilized tube life can prevent the lost opportunity on both unrealized production
15 through running them too cool and tube life "giveaway" if good tubes are discarded prematurely.

16 Typically, destructive testing is used on a small number of tubes removed from the
17 reformer to try and determine the absolute life remaining. Whatever method is used, the results are
18 used on a sample size that is not statistically valid. It is preferable that all the tubes be surveyed
19 with a NDE technique to characterize their relative condition in order to make sense of the absolute
20 condition assessment provided by the destructive testing.

1 Reformer tubes undergo creep strain, in the form of diametrical growth, on the first day

2 that they are fired. The ability to accurately measure and record this growth means that the tubes'

3 condition can be monitored on day one. Therefore, not only can individual tubes be retired from

4 service at an appropriate time, but also the reformer as a whole can be assessed for performance.

5 Another problem that can occur in reformer tubes is metal dusting. Metal dusting is a

6 condition where the process stream attacks the interior of the reformer tube with subsequent,

7 significant metal loss. This can be severe enough to be the life limiting condition for the tube.

8 Typically, the metal dusting damage is limited to a 360° circumferential band around the

9 catalyst tube's interior surface where the critical temperature range exists.

10 External diameter measurements have been used but they are limited as the automated

11 devices only measure across one diameter and are often access-restricted by tube bowing. Manual

12 measurements are too time consuming to provide more than a few readings per tube. No external

13 measurement method can provide diameter growth data at or through the reformer refractory.

14 External measurements are inherently less precise as they are based on a cast surface rather than the

15 internal machined surface and do not take into account the effects of oxide shedding. The most

16 accurate growth measurements are obtained when 'as new' baseline data has been taken prior to the

17 tube being fired for the first time. However, if this is not available by using the top portion of the

18 tube that is operating outside the creep temperature as a reference diameter, the growth profile of

19 the tube can be determined at any stage in its life.

1 Accordingly, there is a need for an automated method and apparatus capable of examining
2 the internal surfaces of reformer tubes. The method should be nondestructive and provide both
3 absolute and relative information on tube profile.

4

5 Brief description of the Invention:

6

7 The Invention provides a method for nondestructive automated inspection of 100% of the
8 tube length from the reformer. Included within the scope of the invention is a probe capable of
9 moving through the tubes where inspection is required. The probe includes a light source and a
10 means for detecting the reflection of the light on the surface of the reformer tube. The reflected
11 light produces an electrical signal from which the profile and reflectivity of the surface of the tube
12 may be reconstructed. Signal processing means are provided to reconstruct the surface from the
13 signal.

14 A first embodiment of the invention uses a solid-state laser diode. A focusing lens is located
15 in front of the diode to focus the laser at a spot on the surface of the tube sought to be inspected.
16 The diode and focusing lens are rotatable within the tube to allow the spot to form a ring as they are
17 rotated. As the probe moves through the tube the spot scans the entire surface. A photo detector is
18 arranged behind an imaging lens to detect the intensity of the spot. Both the detector and the
19 imaging lens rotate in the same fashion as the laser diode and its focusing lens. The optical paths
20 are selected so that the diode, photo detector and surface of the tube form a triangle. The distance

1 between the detector and diode is fixed. This results in the reflected spot moving on the surface of
2 the photo detector in proportion to the distance to the internal surface of the tube. Signal processing
3 means can then use that information to reconstruct a three dimensional image of the internal surface
4 of the tube. The image may either be displayed on a monitor or printed for later review.

5 With present technology a 15-meter tube can be inspected within three minutes. An
6 inspection such as this will provide over 1,000,000 radius readings. The method provides means to
7 compress this information to allow easy manipulation and analysis.

8 A second embodiment uses laser or light emitting diode (LED) and a cone shaped reflector
9 to project a ring of illumination on the interior of the tube sought to be inspected. A charge-coupled
0 device (CCD) is arrayed so as to scan the ring and report the reflectivity and profile. Signal
1 processing circuitry reconstructs an image of the interior of the tube.

12 The use of the internal laser mapping technique is not only useful in preventing tube failure
13 but has huge potential in optimizing production from the whole tube set without sacrificing
14 reliability.

15 Brief Description of the Figures:

16 Figure 1 is a block diagram of a first embodiment of the Invention

17 Figure 2 is diagram of the optical components of the Figure 1 embodiment.

18 Figure 3 is a perspective detail view of the probe of the invention.

19 Figure 4 is a block diagram of a second embodiment of the Invention.

20 Figure 5 is diagram of the optical components of the Figure 4 embodiment.

1

2 Detailed Description of the Figures:

3

4 Figure 1 is a block diagram of a first embodiment of the invention. Components may be
5 either hardware components or software modules as described below. The probe includes a light
6 source 1. The purpose of the light source 1 is to project a spot of light on the surface (not shown)
7 sought to be inspected. Light source 1 is typically a laser diode or light emitting diode (LED). A
8 light source controller 2 is connected to light source 1. Controller 2 sets and controls the optical
9 power level of light source 1. The power level may either be fixed or varied to produce a preset
10 signal level.

11 A position sensitive photo detector (PSD) 3 is situated so as to detect the spot made by light
12 source 1. Photo detector 3 may be a lateral effect photodiode, photodiode array, or charge coupled
13 device (CCD). This description assumes the device chosen for 3 is a lateral effect photodiode.
14 Detector 3 may have either one or two axes, dependant upon the specific measurement geometry.
15 In this description only a single axis detector and associated lens (not shown) is used. Similarly a
16 2D detector may be used for 3 if the light beam from light source 1 is rotated, by means of a
17 rotating mirror, and detector 3 is fixed. An amplifier filter 4 is connected to detector 3. Amplifier
18 /filter 4 converts the small signal currents generated by detector 3 into voltages. A filter sets the
19 bandwidth of the system. The required bandwidth is determined by a combination of the speed of
20 probe spin and the required sample rate. Amplifier and filter may be combined into a single unit by

1 inserting active components into a differential amplifier to produce an active filter. A suitable
2 amplifier may be an integrated circuit differential amplifier such as an AD712. A feedback path is
3 provided between amplifier/filter 4 and light source controller 2 to allow control of light source 1
4 dependant upon the intensity of signal received at detector 3. One or more gain systems 6 may be
5 connected to the output of amplifier /filter 4. This embodiment shows 2 gain systems (5 and 6)
6 each providing a different level of gain. The addition of one or more additional gain systems
7 increases the dynamic range of the system and allows rapid changes of surface reflectivity to be
8 measured. The outputs of the several gain stages are recorded simultaneously, and the largest value
9 that is below saturation is used. Several gain systems may be connected in parallel to provide
usable signals in all situations.

10
11 A normalization and synchronization processing circuit 7 is connected to the output of gain
12 system 6. The first function of system 7 is to select the signal from multiple gain systems 6 with the
13 maximum dynamic range without saturation. The second function is to convert the individual
14 detector readings to a calibrated measurement of the distance between light source 1 and the surface
15 sought to be scanned. For a 1D detector the calibration may be found by solving the following
16 equation:

$$17 \quad Measurement = g \cdot \frac{v_1 - v_2}{v_1 + v_2}$$

18 In the equation, v_1 and v_2 are the current readings from either end of detector 3. (g) is a
19 calibration function used to remove non-linearity in the detector and optics. (g) may be determined

1 empirically by scanning calibrated tube samples of various diameters and using the resultant data
2 points to find coefficients of the function (g). As an alternative to the calculation using (g) in the
3 above equation, a lookup table with some form of interpolation may be used. In order to eliminate
4 electronic drift the system periodically turns light source 1 off and measures electronic offset
5 voltages. The offset voltages are then subtracted from subsequent readings made with light source 1
6 on. Normalization and synchronization processing circuit 7 also measures the surface reflectivity.
7 The reflectivity of the surface is computed from the detector signal level, gain, and light source
8 power level. Variations in surface reflectivity can provide useful information about the surface.
9 Normalization and synchronization processing circuit 7 also collects data from a rotational encoder
10 in 8. The correlation of the signals from encoder in 8 and from photo detector 3 assures equally
11 spaced samples around the circumference of a tube.

12 Two motors 11 and 12 move the probe. The first motor 11 rotates the probe within a tube.
13 A motor drive circuit 13 controls motor 11. Encoder 8 is connected to motor 11 allowing
14 determination of the absolute rotational position of the probe. The output of encoder 8 is connected
15 to normalization and synchronization processing circuit 7. A second motor 12 provide axial
16 positioning of the probe. A second motor drive circuit 14 controls motor 12. An axial incremental
17 encoder 15 connected to motor 12 provides information on the axial position of the probe in the
18 tube.

19 A system data storage display and control module 16 provides overall control of the probe.
20 Module 16 receives information on the distance between light source 1 and the surface sought to be

1 inspected and surface reflectivity from normalization and synchronization processing circuit 7.
2 Module 16 also receives information about the axial position of the probe from encoder 15.
3 Module 16 controls the rotational position of the probe in the tube by sending an on and off signal
4 to rotational motor drive circuit 13. Module 16 also controls the axial position by sending on/off
5 and forward/backward signals to axial motor control circuit 14.

6 Figure 2 is diagram of the optical components of the Figure 1 embodiment. A light source
7 1 produces beam of light. Light source 1 is usually a diode laser but could be a light emitting diode
8 in special applications. A collimating lens 21 downstream of light source 1 converts the light
9 emitted by light source 1 into a collimated beam which does not spread to any appreciable extent
10 over the inspection range 22'-22". The beam produces a target spot 22 where it impacts the target
11 surface 23. A photo detector 27 is mounted at an angle to the optical train of components 1, 21,
12 and 22. The angle is detected such that the imaged spot at 26 is in focus over the measurement
13 range 26' to 26". Photo detector 27 is usually a lateral effect photodiode array or charge coupled
14 device (CCD) photo detector. Photo detector 27 may either be a one dimensional (1D) or two
15 dimensional (2D) device. If photo detector 27 is a 2D device additional information may be
16 generated at the expense of greater bandwidth. An imaging lens 24 is mounted in front of photo
17 detector 27. Imaging lens 24 projects an image of the surface of target 23 onto photo detector 27.
18 The image projected onto photo detector 27 includes an image 26 of the spot 22 where the
19 collimated beam impacts the target. The position of imaged spot 26 varies with the distance from
20 light source 1 to target 23 due to parallax. If, for example, the surface of target 23 is at 22' the

1 imaged spot is at 26'. Similarly, if the target is at 22" the imaged spot will be at 26". The result is
2 that imaged spot 26 moves back and forth across the surface of photo detector 27 in an amount
3 relative to the distance between target surface 23 and light source 1. Photo detector 27 thus
4 generates an electrical signal containing information about the distance between 1 and 23.

5 The complete optical system, as described, is rotated around the central axis of the probe in
6 order to scan the complete circumference of the tube. Other embodiments modify the basic optical
7 system to reduce the need for slip rings for the electrical signals required by the laser diode and
8 detector. By locating the laser diode source and collimating lens on axis with the probe longitudinal
9 axis and using a rotating 45° mirror to deflect the light beam at a right angle to the probe
longitudinal axis, the beam can be made to scan the circumference of the tube. A second mirror
10 and imaging lenses are also rotated with the first mirror, to form an image of the light spot onto a
stationary 2D PSD. This approach has the advantage of eliminating slip rings from the probe. The
disadvantage is that the 2D PSD provides 4 outputs instead of 2, and requires more processing to
compute the radius data. Another disadvantage of this method is that a transparent tube or windows
in the housing are required to support the laser diode and detector, while still allowing a light path.
11
12 The window or transparent tube is subject to scratches or dirt that provide reflection paths for light
13 leakage between the laser diode source and the detector. These light leakage paths cause errors in
14 the radius measurement. Also, the electrical wires necessary to connect to either the diode or
15 detector must cross the path of the light beam at some point in the rotation of the lens/mirror
16
17
18
19

1 assembly. Other variations of the optical arrangement are possible. The embodiments described
2 herein are not intended to limit the scope of the invention, but rather are for illustrative purposes.

3 Figure 3 shows a detailed profile view of the probe of the first embodiment in this
4 invention. The probe consists of a rotating optical head 30 mounted to a body 31.

5 The relative size of the reformer tubes presents other challenges to laser-optical probe
6 design. Previous probes of this type have been for smaller diameter tubing, up to 2-inches in
7 diameter. For larger diameter tubes, such as reformer tubes, the weight and inertia of the
8 probe and its rotating components must be reduced to make the approach practical. In one
9 embodiment of the system, the probe head 30 is spinning at 1800 rpm. Replacing a metal
10 spinning head with one made of Delrin™, an engineering plastic made by Dupont, provides
11 weight and inertia reduction while maintaining structural strength, thermal stability, and
12 impact resistance.

13 The probe body 31 is made relatively small compared to the diameter of the reformer
14 tube. This allows weight reduction, and has the benefit of allowing the same probe body to be
15 used in several different tube sizes by changing the centering spring assemblies, and the probe
16 head. Weight reduction is important in the reformer tube application because the probe is
17 drawn through the tube by a motorized positioning system. Reducing the weight reduces the
18 size and cost of the positioning system.

19 A tether and electrical connections are made to the probe through connector 32.
20 Electrical connections between the connector and the optical head are made through the probe

1 body by means of an internal slip ring. Probe rotation is by means of a motor inside probe
2 body 31. Centering rings 35 are spring loaded arms with non-metallic wheels to hold the
3 probe in the center of the tube, and allow for axial motion through the tube.

4 Reformer tubes are made of special alloys to withstand the temperature and pressure
5 regimes to which they are subjected. During normal operation, portions of reformer tubes
6 operate at or near the structural stability limit of the tube metallurgy. If the probe leaves any
7 traces of other metals on the inner tube surfaces, such as aluminum or lead, the traces of these
8 metals will enter the pores of the tube wall and cause rapid cracking and failure of the tube.
9 Therefore, it is important that only non-metallic components be used where the probe is in
10 contact with the tube surface. The probe's centering spring mechanism 35 contacts the sides
11 of the tube with wheels 36 made from Delrin™, an engineering plastic with metal-like
12 properties.

13 One of the problems that affects accuracy in PSD based laser triangulation systems is
14 when unintended reflections cause additional light to impinge on the sensor. These reflections
15 arise when light reflects from the surface being measured, bounces off other surfaces and
16 enters the detector from various angles. Because the PSD sensor measures the centroid of the
17 light imaged on its surface, reflections cause a skewing of the image centroid. The present
18 invention minimizes reflections by placing the laser 37 at the front of the probe head and in
19 front of the detector 38. In contrast to designs with the laser behind the detector, this reduces

1 the exposure of the detector to light reflections off the probe head 30, body 31, and centering
2 spring assemblies 35.

3 Figure 4 is a block diagram of a second embodiment of the invention. This embodiment
4 projects a ring shaped spot of light onto the interior surface of the reformer tube. The ring shaped
5 spot is then scanned with an array of light sensors to produce and reconstruct an image of the
6 interior of the tube.

7 A light source 40 is connected to a power controller 41 to maintain a light level sufficient to
8 be sensed by an image detector. Typically light source 40 is a laser diode with output in the infrared
9 or visible portion of the spectrum. A light detector 42 is positioned in such a manner as to view an
10 image of the ring of light. Light detector 42 is a two dimensional array of photosensitive cells.
11 Most commonly detector 42 is a Charge Coupled Device (CCD) array of photocells. Such arrays
12 are commonly used in video cameras. Array 42 is divided into individual pixels each represented by
13 an X coordinate and a Y coordinate. The signal from each pixel is proportional to the intensity of
14 light falling on that pixel. The detector is controlled by a timing and control module 43. In
15 general, module 43 scans the array in a line-by-line fashion. Each individual line is moved to an
16 output register. The individual pixels are then shifted out in a serial operation. The CCD array is
17 of the Frame Transfer type that uses two identical CCD arrays, one for scanning and one for
18 storage. The second array is shielded from light and acts a buffer to allow reading an image while a
19 second image is being formed on the first array.

1 A typical sensor is a 512x512 array having 262,144 elements or pixels. Typically, there are
2 additional light shielded pixels in the array that provide buffering of the active pixels. This
3 increases the number of total pixels that must be read. A typical 512x512 array requires a clock
4 speed of 80Mhz to read out with time for the buffer pixels, transferring the frame, etc., for a
5 120Hz frame rate. Some arrays have a split output structure, so that two pixels are read at a time.
6 This reduces the clock rate to 40Mhz, but requires two parallel output-processing channels. In
7 tested prototypes the ring image has a thickness of 3-5 pixels. At the maximum radius the number
8 of pixels actually used is

$$2 \cdot \pi \cdot r \cdot 5 \approx 8k \text{ pixels}$$

Where r , at the maximum radius is 256 for a 512x512 array. In other words each frame will hold about 8k pixels of useful information.

1 During use, array 42 converts the image to an array of intensity values. The Analog
2
3 Digital Converter 44 connected to Array 42 converts this analog signal to a digital one. An eight-bit
4
5 A to D converter has been found suitable for 44. The signal next goes to a Look-Up-Table (LUT)
6
7 45 to convert the Cartesian X, Y coordinates received from the Timing and Control Module 45 into
8 radial coordinates r, θ . LUT 45 may be a logical array or an addressable device such that when an
9 X, and Y address is input, a value for r and θ is provided. This may be done with non-volatile
10 memory devices such as ROM, PROM, EPROM, EEPROM, flash memory, or a volatile memory
11 such as static or dynamic RAM. The speed of operation required for this embodiment dictates the
12 use of volatile memory, such as synchronous RAM. The access time must be under 30

1 nanoseconds for a 512x512 array. A 256k x 18 device provides 9 bits each for r and θ. For a 10-bit
2 θ, the MSB of the Y address value can be added to θ to form 10 bits. A 9-bit θ is used for 360
3 points per rotation, 10 bits for 720 points per rotation, for 1/2° resolution.

4 The X and Y address of each pixel is fed to the address lines of LUT 45 at the same
5 time that the value of intensity for the pixel is available from the A to D converter 44. Because
6 LUT 45 is a volatile memory device, it must be loaded with the lookup values before use. This may
7 be done on power up of DSP 50 or host PC 51. LUT 45 is programmed with the corresponding r
8 and θ for each X and Y address of sensor 42 according to the following formulae:

$$r = \sqrt{X^2 + Y^2} \quad , \quad \theta = \tan^{-1}\left(\frac{Y}{X}\right)$$

9
10 The intensity value from array 42 and the r,θ values from LUT 45 are sent to a
11 Data Range Control module (DRC) 46. DRC 46 reduces the amount of data used in further
12 processing steps. The actual image from array 42 includes only about 8k of pixels out of a typical
13 256k pixels in a 512x512 array. The pixels of interest are in a circular area in the outer third of the
14 array. The definition of the pixels of interest t is $r > r_t$ where r_t is the radius threshold value and is
15 the minimum r value of interest. No image data ever occurs at r-values less than r_t . DRC 46
16 includes logic circuitry which only passes to FIFO 47 the information of interest i.e. $r > r_t$.

17 Even with the use of DAC 49 there are still too many pixels without useful information for
18 easy processing. For example in a 3-in ID pipe with a probe measuring range from 2.25 in to 2.75
19 in. radius and a 512x512 array the measuring range will cover 85 pixels with r having a range of

1 from 171 to 256. If r_t is set to 170 there are still over 170,000 pixels per frame to be processed.
2 Only the pixels that are illuminated by the light source 40 provide useful information. Since only
3 pixels with intensity over a certain threshold are of interest that fact may be used to eliminate
4 surplus pixels. A high-speed comparator 48 is used to compare the intensity value of each pixel
5 with a threshold value I_t . The output of comparator 48 triggers the data selection to pass only the
6 data including r , θ , and I , where I is greater than the threshold I_t . This reduces the data sent to
7 FIFO to about 8k pixels. The threshold value I_t is set with a DAC device 49. DAC 49 is set from
8 the host system via the DSP controller 50 during calibration.

9 Since the actual data rate is greater than 40 MHz accordingly; a FIFO 47 is used to buffer
10 the data at that rate. Data entering FIFO 47 clocks at the scan rate of the array 42 but is sporadic
11 and has many gaps due to the action of the data selection effect of DRC 46 and comparator 48.
12 FIFO 47 buffers the data for DSP 50, which is thus able to read the data at a slower rate. DSP 50
13 must still process all 8k of data in under 8.3 milliseconds in order to process 120 frames/sec. FIFO
14 47 will buffer one frame of data for an 8k FIFO or two frames for a 16k FIFO.

15 The Digital Signal Processor (DSP) 50 performs the actual computation of the radius of the
16 tube by finding the centroid of the imaged light on each radial spoke θ_k where k indexes the angle
17 through 360 or 720 increments depending on the resolution. The centroid for each radial spoke θ_k is
18 computed according to the following formulae:

$$\frac{\sum r_i \cdot I_i}{\sum I_i}$$

1 Where r is the radius value from 0 to 255 for a 512x512 array, and I is the corresponding
2 intensity value for that pixel, i is the index value for the array of points comprising the radial spoke.
3 In practice, i starts at a radius much larger than 0 since the image is set in the outer third of array
4 42. A DSP 50 of sufficient speed can perform the division and provide the radius value directly. If
5 a lower speed DSP 50 is used it can compute the numerator and denominator of the above equation
6 and provide the values as separate outputs. A post processing operation in host PC 51 computes the
7 actual radius value and converts the output to engineering units such as inches or millimeters. The
8 processed data is sent to host PC 51 via a high-speed interface; suitable methods include serial
9 interfaces such as RS232, RS485, USB, or IEEE-1394 (Firewire) or parallel interfaces such as a
0 PC parallel port or EPP.

1 Host PC 51 receives the data from the probe processing system, and does any post
2 processing of the data and formats it for storage on hard disk or removable media storage and
3 displays the data on a graphics screen.

4 Figure 4 illustrates an implementation having a single processing channel. For an image
5 sensor with a dual output structure, another channel of processing is added with another A/D
6 converter, LUT, Data Range Controller, comparator, and FIFO.

7 Figure 5 is a front elevation view of the optical system of the figure 4 embodiment. The
8 components are located in a tube 64 sought to be inspected. A laser diode 61 is located at the center
9 of tube 64 in such a manner that the light emitted by diode 61 is parallel to the axis of tube 64. A
0 collimation lens 62 is located on said axes to focus the light on the interior surface of tube 64. A

1 cone mirror 63 is located coaxial to diode 61 and lens 62 to form the light emitted from diode 61
2 and collimated by lens 62 into a ring shaped spot 65 on the surface of tube 64. Mirror 63 is
3 preferably a parabolic conical mirror to aid in focusing the beam on the interior surface of the tube.
4 An imaging lens 66 coaxial with diode 61 lens 63 and mirror 63 is situated in such a manner as to
5 project an image of ring shaped spot 65 onto the surface of an imagining array 67. Imaging array
6 67 senses the image projected onto its surface and converts the image into electrical signals.

7 The above examples and embodiments are exemplary only the invention being
8 defined solely by the attached claims.

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I claim:

1. A device for inspecting the interior of metal tubes used in chemical processing for the presence of metal dusting and creep comprising a source of light adapted for focusing a spot of light on the interior surface of said tubes; means for focusing said light source on the interior surface of said reformer tube, and a detector for detecting said spot of light focused on the interior of said reformer tube, and means for centering said source and said detector in the center of said tube; and means for moving said detector, source, and centering means through said detector tube.
2. A device for inspecting the interior of metal tubes used in chemical processing for the presence of metal dusting and creep as in claim 1, wherein said means for focusing said spot on the surface of said reformer tube includes a laser source and optical detector in a rotating head for rotating said spot around the inner circumference of said reformer tube.
3. A device for inspecting the interior of metal tubes used in chemical processing for the presence of metal dusting and creep as in claim 2 wherein said source is positioned forward of said detector in a direction away from the probe body and centering device.
4. A device for inspecting the interior of metal tubes used in chemical processing for the presence of metal dusting and creep as in claim 1, wherein said centering device is adapted for use in reformer tubes by preventing chemical interaction with the inside surface of said reformer tube.
5. A device for inspecting the interior of metal tubes used in chemical processing for the presence of metal dusting and creep as in claim 4, wherein said centering device is

constructed so that all surfaces which may potentially contact the interior of said tube are constructed out of nonmetallic materials.

6. A device for inspecting the interior of metal tubes used in chemical processing for the presence of metal dusting and creep as in claim 1, wherein said focusing means includes a conical mirror for projecting a focused ring of light on the interior surface of said reformer tube.
7. A device for inspecting the interior of metal tubes used in chemical processing for the presence of metal dusting and creep as in claim 6, wherein said conical mirror is parabolic to focus said ring to a small circumferential line.
8. A device for inspecting the interior of metal tubes used in chemical processing for the presence of metal dusting and creep as in claim 6, further comprising signal processing means to reduce the bandwidth of information transported out of said reformer tube.
9. A method for forming a profile of the radius of the interior of a tubular structure comprising the steps of; producing a light beam on the axis of said tube, collimating said beam to focus on the surface of said tube, forming said collimated beam into a ring on the surface of said tube, projecting an image of said ring onto the surface of a sensor and moving said ring down the axis of said tube.
10. A method for forming a profile of the radius of the interior of a tubular structure as in claim 9, further comprising the step of reflecting said beam off the surface of a conical mirror.
11. A method for forming a profile of the radius the interior of a tubular structure as in claim 9, further comprising the step of reflecting said beam off the surface of a conical

mirror with a parabolic surface for maintaining focus of said beam on the expected tube diameter.

12. A method for forming a profile of the radius of the interior of a tubular structure as in claim 9, further comprising the steps of, reflecting said beam off a mirror at the axis of said tube, and rotating said mirror to produce a ring of light on the surface of said tube.
13. A method for processing a signal that includes X, Y, and intensity data sets for each pixel of said sensor from an image sensor receiving a substantially ring shaped image comprising the steps of, converting a signal having an X position, a Y position, and an intensity component to a signal having an angle, a radius, and an intensity and filtering out all signal sets that do not have a radius greater than a predetermined radius.
14. A method for processing a signal as in Claim 13, wherein said converting step is accomplished by use of a look-up table for rapid conversion of X and Y pixel addresses to an angle and a radius.
15. A method for processing a signal as in Claim 14, wherein said look-up table is loaded during initialization of said system.
16. A method for processing a signal that includes X, Y, and intensity data sets for each pixel of said sensor from an image sensor receiving a substantially ring shaped image as in claim 13, comprising the further step of discarding all data sets whose intensity signal does not exceed a predetermined value.
17. A method for processing a signal that includes X, Y, and intensity data sets for each pixel of said sensor from an image sensor receiving a substantially ring shaped image

as in claim 16, where in said predetermined value is set during calibration to include only a range of. Values within an expected deviation of the radius of said tube.

18. A method processing a signal that includes X, Y, and intensity data sets for each pixel of said sensor from an image sensor receiving a substantially ring shaped image as in claim 16, where in said predetermined value is set during calibration to include only a range of values within a expected deviation of the intensity of a reflected signal
19. A method processing a signal that includes X, Y, and intensity data sets for each pixel of said sensor from an image sensor receiving a substantially ring shaped image as in claim 16, comprising the further step of converting the analog output of an image sensor into a digital signal by synchronizing the clock of the image sensor with the intensity output to produce said X and said Y signal.
20. A method processing a signal that includes X, Y, and intensity data sets for each pixel of said sensor from an image sensor receiving a substantially ring shaped image as in claim 16, comprising the further step of storing each angle, radius, intensity, data set in a register for later download and processing.
21. A method processing a signal that includes X, Y, and intensity data sets for each pixel of said sensor from an image sensor receiving a substantially ring shaped image as in claim 20, wherein only values within a preselected range are stored in said register.
22. A method for inspecting a reformer tube for chemical processing for damage including creep and metal dusting comprising the steps of shining a spot of light onto the interior of said tube and detecting the reflection of said spot by converting light into an electrical signal, processing said signal to determine the radius of said tube.

23. A method for inspecting a reformer tube for chemical processing for damage including creep and metal dusting as in claim 22 comprising the further step of rotating said spot by reflecting it off the surface of a rotating mirror.
24. A method for inspecting a reformer tube for chemical processing for damage including creep and metal dusting as in claim 23 wherein said detecting step is preformed by a charge coupled detector array.
25. A method for inspecting a reformer tube for chemical processing for damage including creep and metal dusting as in claim 24 wherein said detector array is positioned aft of said spot of light.
26. A method for inspecting a reformer tube for chemical processing for damage including creep and metal dusting as in claim 22 comprising the step of reflecting said spot off a conical mirror to focus said spot into a ring on the interior surface of said tube.
27. A method for inspecting a reformer tube for chemical processing for damage including creep and metal dusting as in claim 26 comprising the further step of processing said signal in said tube to remove unneeded information.
28. A method for inspecting a reformer tube for chemical processing for damage including creep and metal dusting as in claim 26, wherein dynamic range is increased by the use of multiple parallel gain stages.
29. A device for inspecting the interior of metal tubes used in chemical processing for the presence of metal dusting and creep as in claim 1, wherein the rotating portions of said device are adapted for high speed operation above 1500 revolutions per minute.

30. A device for inspecting the interior of metal tubes used in chemical processing for the presence of metal dusting and creep as in claim 29, wherein said high speed operation is achieved by using a material that is substantially lighter than metal for the body of said device.

31. A device for inspecting the interior of metal tubes used in chemical processing for the presence of metal dusting and creep as in claim 30, wherein said body is substantially smaller than the inside diameter of the tube sought to be inspected allowing inspection of several tube diameters.

ABSTRACT

A method and apparatus for accurately determining the interior profile of cylindrical objects such as reformer catalyst tubes is described. The radius of the tube is measured from the axis of the tube for each point of the interior surface by calculating the angle of a reflected light beam and the deviation thereof. A first embodiment reflects a light beam off of the interior surface of the cylinder and measures the angle of the light reflected from the interior of the cylinder. A second embodiment removes rotating parts by using a cone mirror to reflect a ring of light onto the interior of the cylinder. Signal processing means are provided to reduce surplus signals allowing transmission of only useful information.

Figure 1

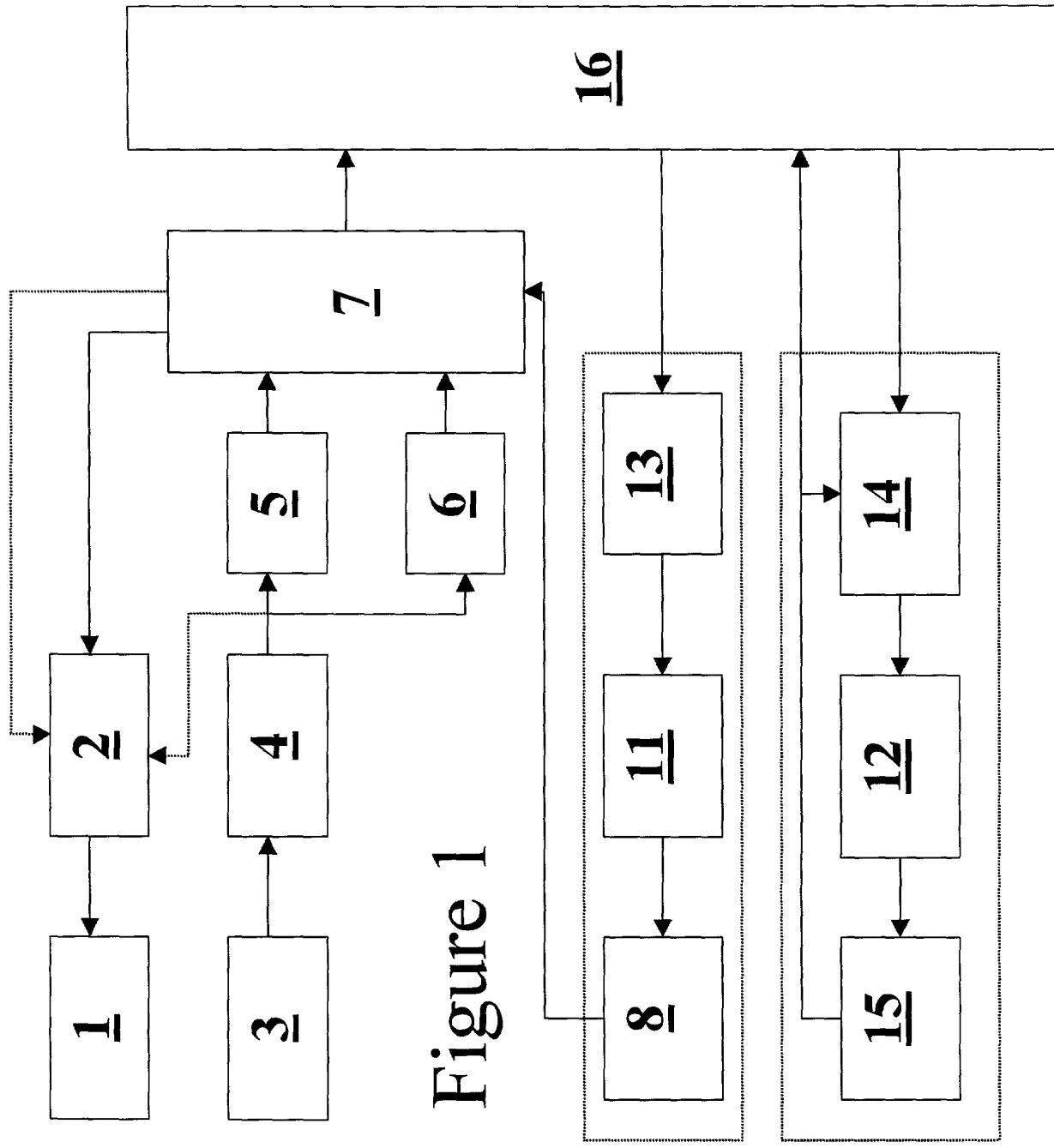
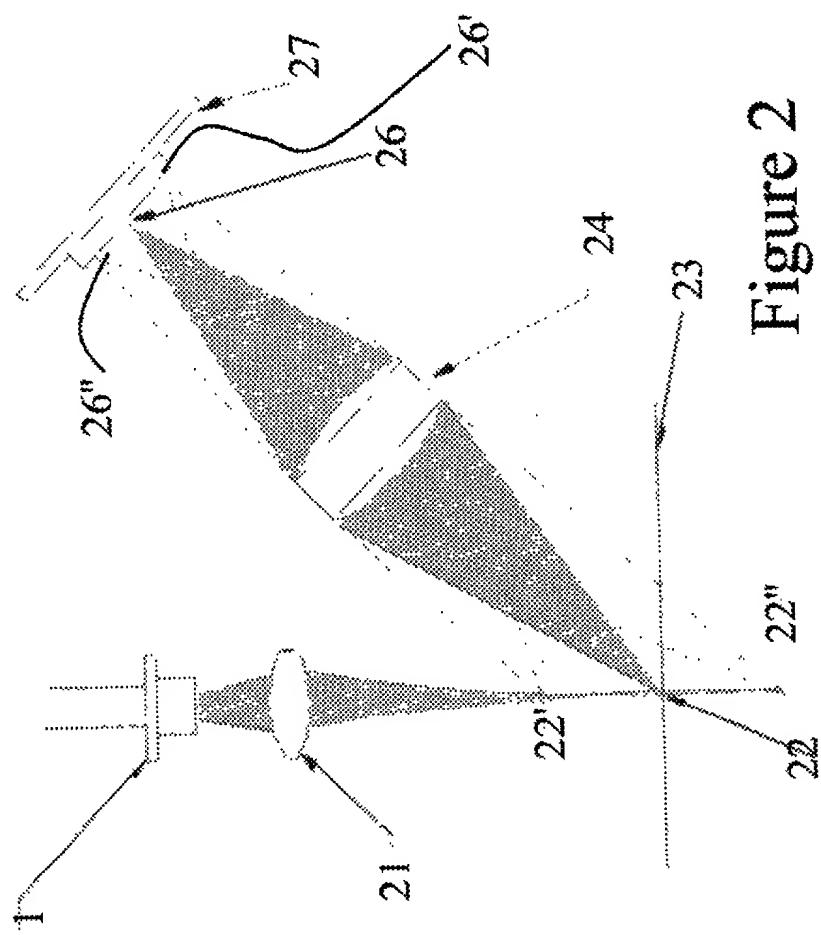


Figure 2



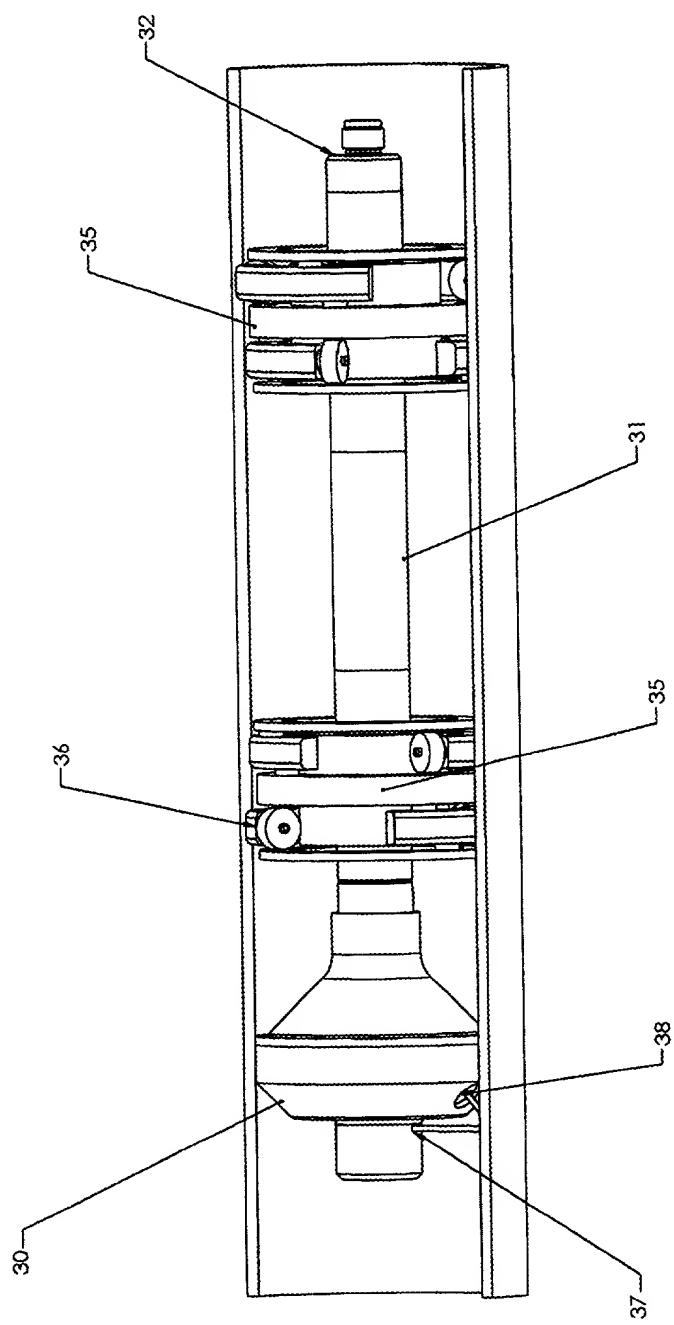


Figure 3.

FIGURE 4

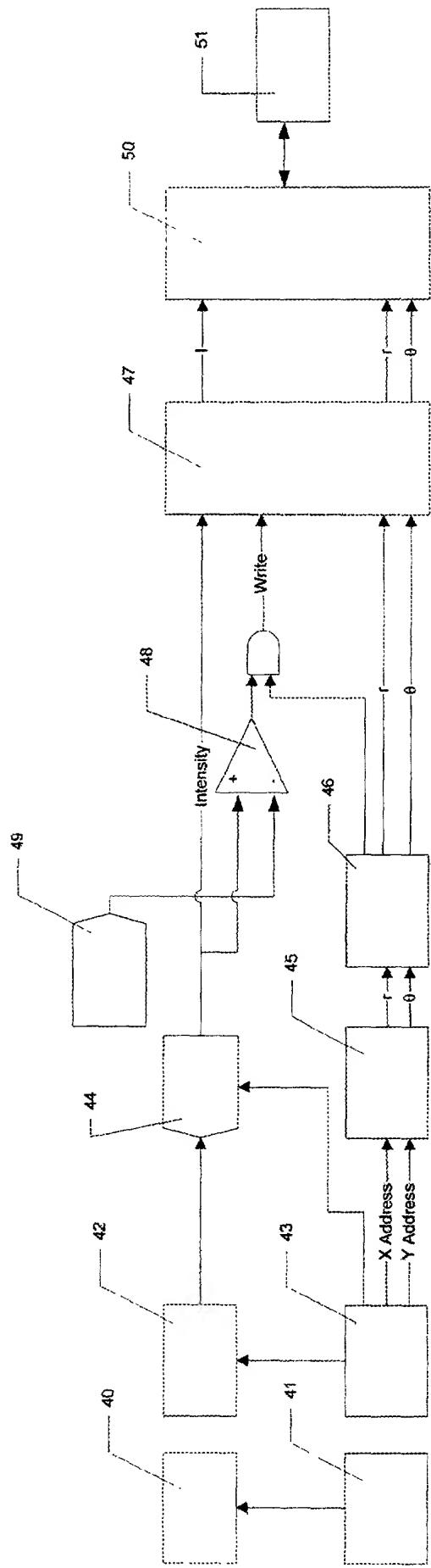
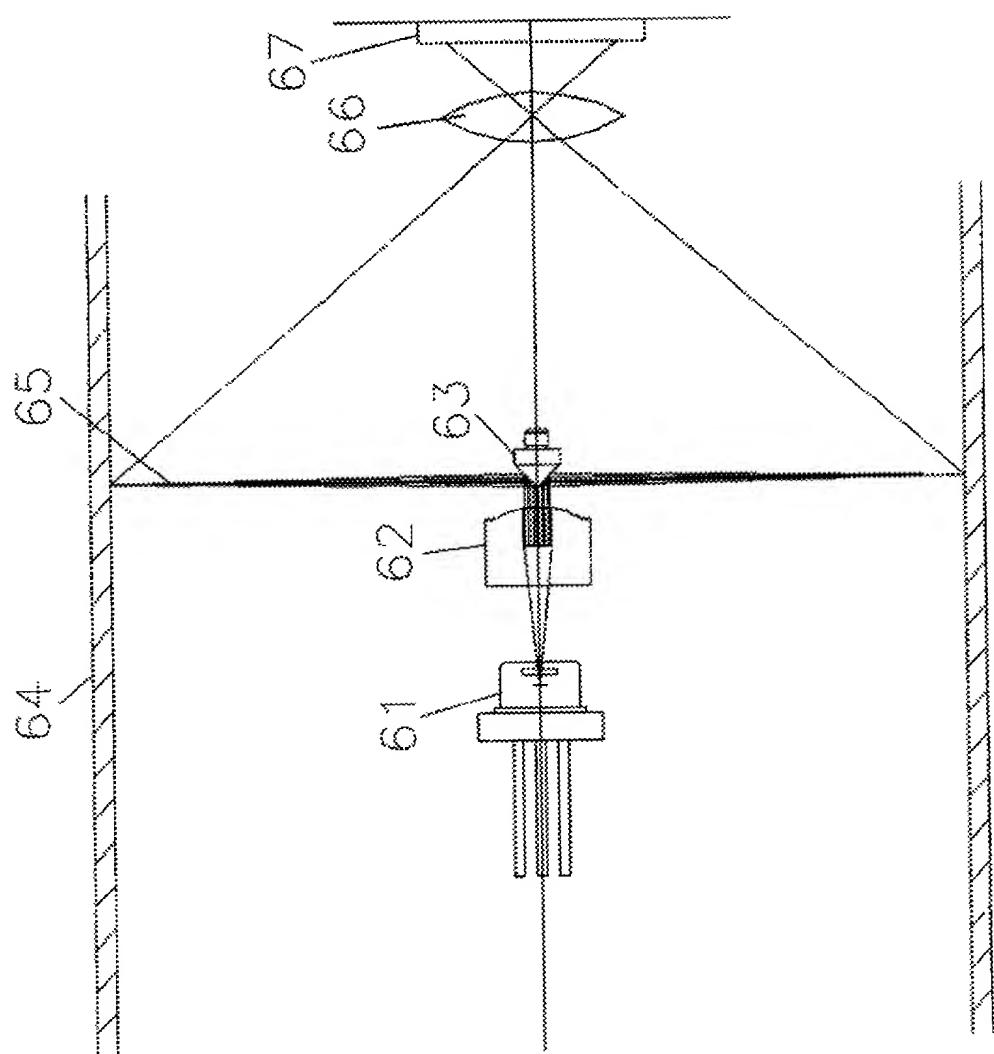


Figure 5



1

2 DECLARATION, POWER OF ATTORNEY, AND PETITION

3

4 We, the undersigned, declare:

5

6 That we reside at the addresses indicated below, which are our post office addresses.

7

8 The specification to which this Declaration is directed is entitled: Method and Apparatus
9 for In Situ Inspection of Reformer Tubes

10

11 That we have reviewed and understand the contents of said specification, including the
12 claims.

13

14 That we believe that we are the original and first inventors of the subject matter which is
15 claimed and for which a patent is sought.

16

17 That we are the sole inventors of the invention claimed.

18

19 That we acknowledge the duty to disclose information, which is material to the
20 examination of this application in accordance with 37 CFR {1.56(a)}.

21

22 That all statements made herein of our own knowledge are true, that all statements made
23 herein on information and belief are believed to be true, and that these statements were made
24 with the knowledge that willful false statements and the like so made are punishable by fine or
25 imprisonment, or both (18 U.S.C. 1001) and may jeopardize the validity of the application or any
26 patent issuing thereon.

27

28 And we hereby appoint Don R. Mollick, Reg. 28,972; attorney of the State Bar of
29 Washington, of the firm of Law Offices of Don R. Mollick, having a business address of 12505
30 Bellevue Redmond Road, Suite 210, Bellevue, Washington 98005, and a telephone number of
31 (205) 454-2700, as my attorney with full power of substitution and revocation, to prosecute this
32 application and to transact all business in the Patent and Trademark Office connected herewith.

33

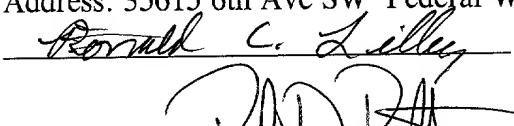
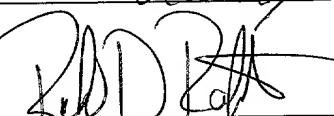
34 Wherefore, we pray that Letters Patent be granted to us for the invention described and
35 claimed in said specification and claims, declaration, power of attorney, and this petition.

1
2 Date 10/23/2000
3 
4 Signature

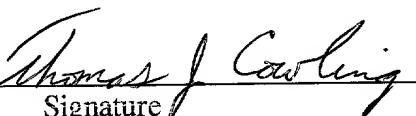
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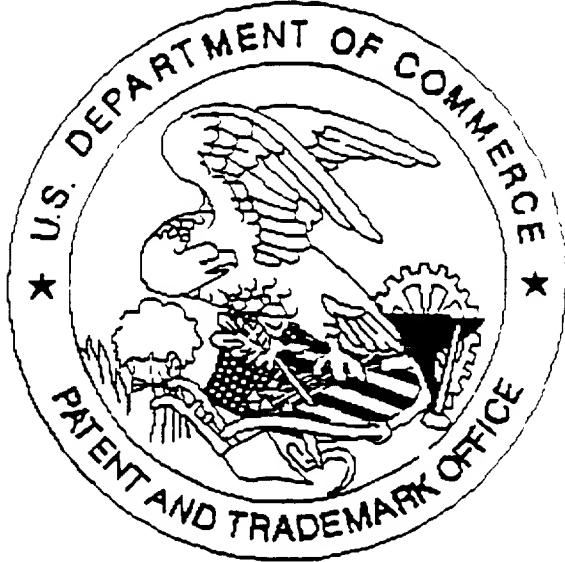
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20 Date 10/26/00 
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